

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	William G. America, et al.	Examiner:	Jack S. J. Chen
Serial No:	10/674,646	Art Unit:	2893
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For:	PLASMA SURFACE MODIFICATION AND PASSIVATION OF ORGANO- SILICATE GLASS FILMS FOR IMPROVED HARDMASK ADHESION AND OPTIMAL RIE PROCESSING	Dated:	April 28, 2009

Confirmation No. 4797

Commissioner for Patents
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RESPONSE UNDER 37 C.F.R. § 1.116


Sir:

In response to the Office Action dated March 4, 2009, Applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website on April 28, 2009.

Dated: April 28, 2009



Leslie S. Szivos, Ph.D.